

Repetition: Physical Deposition Processes

PVD (Physical Vapour Deposition)

Evaporation

Sputtering

Diode-system

Triode-system

Magnetron-system ("balanced/unbalanced")

Ion beam-system

Ionplating

DC-glow-discharge

RF-glow-discharge

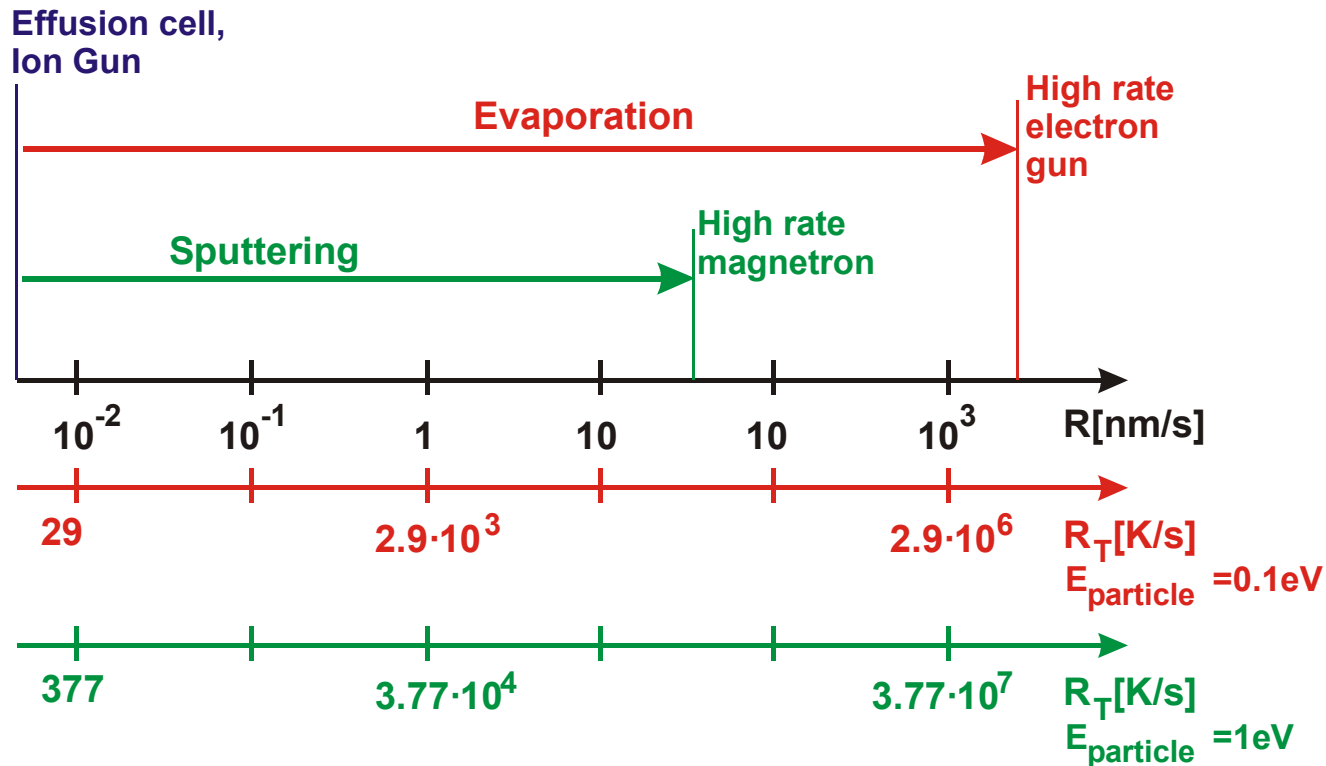
Magnetron- discharge

Arc-discharge

Ion-Cluster-beam

Reactive versions of the above processes

Repetition: Rates and Cooling Rates PVD



These extremely high achievable cooling rates show, that PVD processes (apart from being a direct transition from vapor \rightarrow solid state) often can be considered as non equilibrium processes.

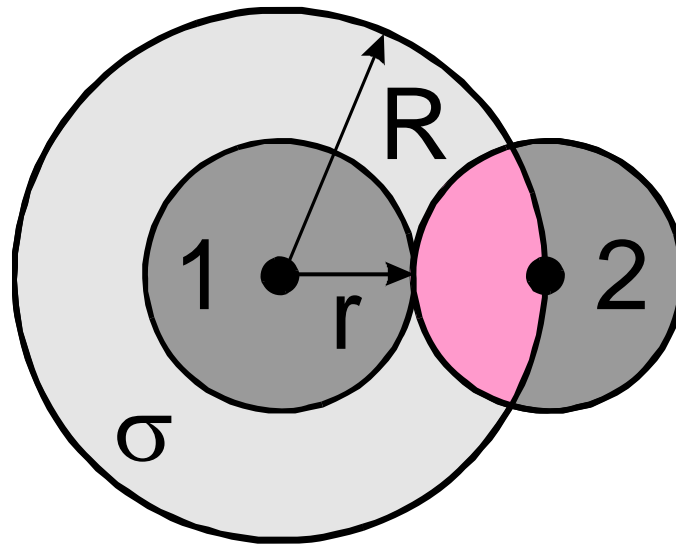
Vacuum Physics

Central Termini:

- **Mean free path:** the way a gas particle (or a film particle) can travel without a collision with another particle.
- **Impingement rate:** number of particles which hit a surface per second and unit area at constant pressure.
- **Coverage time:** time needed for the formation of a full monolayer.

Mean Free Path I

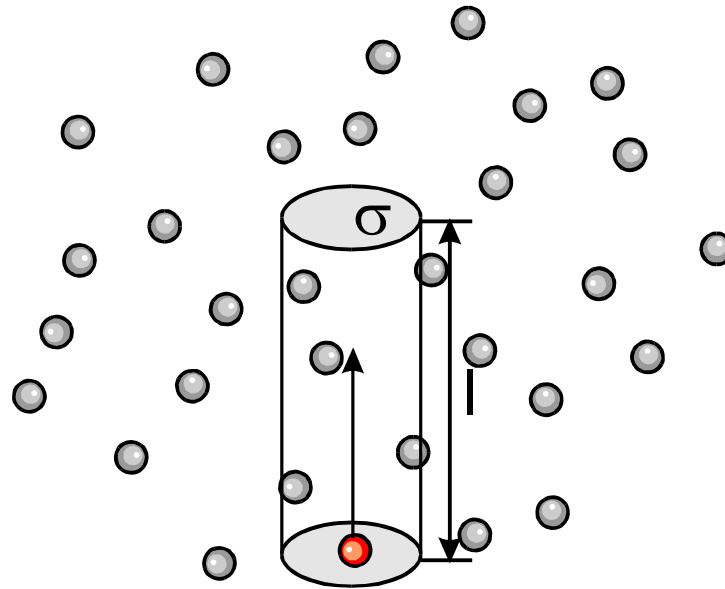
Collision of two particles, 1 and 2 with radius $r = R/2$:



If both particles are considered as **points** then a collision happens, if particle 1 is located within a disk of the **area** $\sigma = \pi \cdot R^2$. σ is called the **collision cross section**.

Mean Free Path II

A particle moves straight for a distance l through a gas. Within a **cylinder of the volume $V = l \cdot \sigma$** it will collide with **each particle located in V** .



The cylinder contains **$N = n \cdot V$** particles. For straight movement this is the **collision number**.

Mean Free Path III

One collision happens if $N = 1$. This yields the **mean free path λ** as:

$$N \equiv 1 \Rightarrow n \cdot V = n \cdot \lambda \cdot \sigma = 1$$

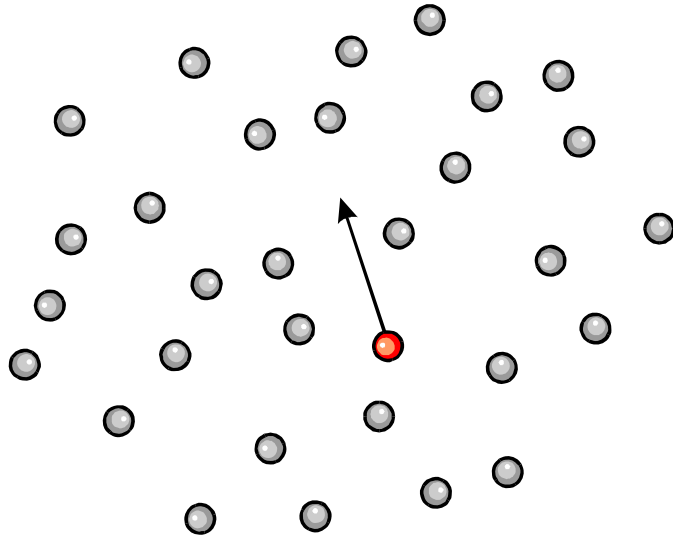
$$\lambda = \frac{1}{n \cdot \sigma} = \frac{1}{\pi \cdot n \cdot R^2} = \frac{1}{4 \cdot \pi \cdot n \cdot r^2}$$

- **Macroscopic information:** Particle density n , from the ideal gas equation.
- **Microscopic information:** Collision cross section σ , contains energy dependent atom/molecule radii or the general interaction cross sections of the colliding particles.

Mean Free Path IV

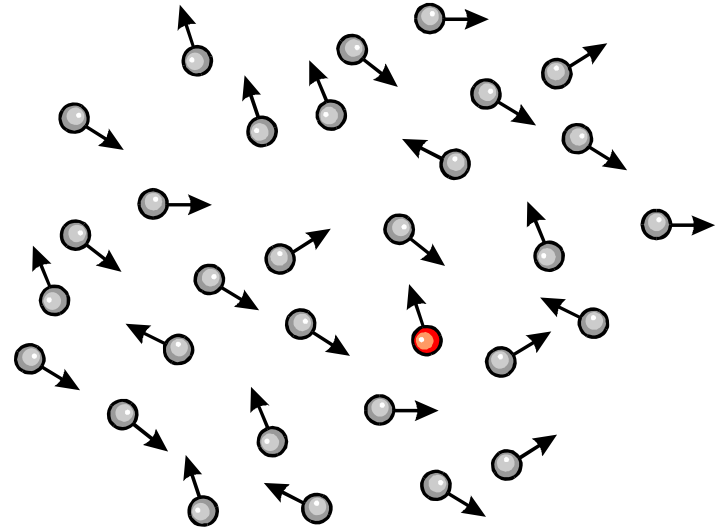
State of movement of the background gas:

**Energetic
coating particle: relative
movement may
be neglected**



$$\lambda = \frac{1}{4 \cdot \pi \cdot n \cdot r^2}$$

**Gas particle:
relative movement
may not be neglected**



$$\lambda = \frac{1}{\sqrt{2} \cdot 4 \cdot \pi \cdot n \cdot r^2}$$

Mean Free Path - Example

$$\lambda = \frac{1}{4 \cdot \pi \cdot n \cdot r^2} \quad p \cdot V = N \cdot k_B \cdot T \Rightarrow \frac{N}{V} = n = \frac{p}{k_B \cdot T}$$

$$p = 0.1 \text{ Pa}$$

$$k_B = 1,38 \cdot 10^{-23} \text{ J/K}$$

$$T = 300 \text{ K}$$

$$r = 1.5 \cdot 10^{-10} \text{ m}$$

$$\lambda = \frac{k_B \cdot T}{4 \cdot \pi \cdot p \cdot r^2} =$$

$$= \frac{1.38 \cdot 10^{-23} [\text{J / K}] \cdot 300 [\text{K}]}{4 \cdot \pi \cdot 0.1 [\text{J} \cdot \text{m}^{-3}] \cdot 1.5 \cdot 10^{-10} [\text{m}^2]} =$$

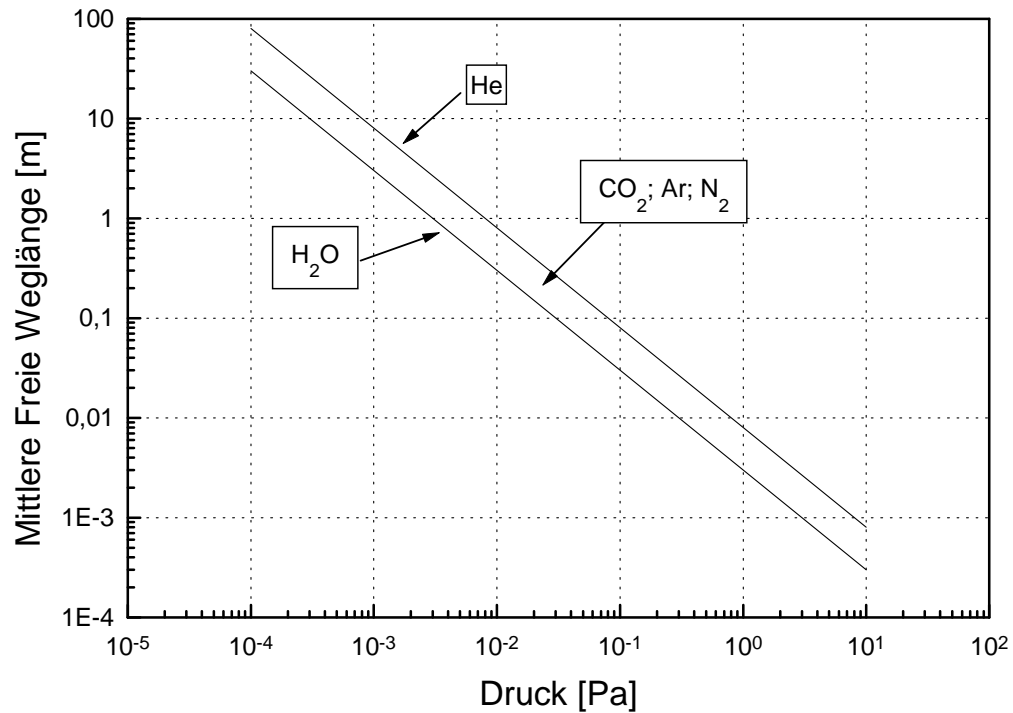
$$= 14.6 \text{ cm}$$

Mean Free Path - Rough Estimate

$$\lambda p = 5 \text{ mm Pa}$$

$$p = 1 \text{ Pa} \rightarrow \lambda = 5 \text{ mm}$$

$$p = 10^{-4} \text{ Pa} \rightarrow \lambda = 50 \text{ m}$$

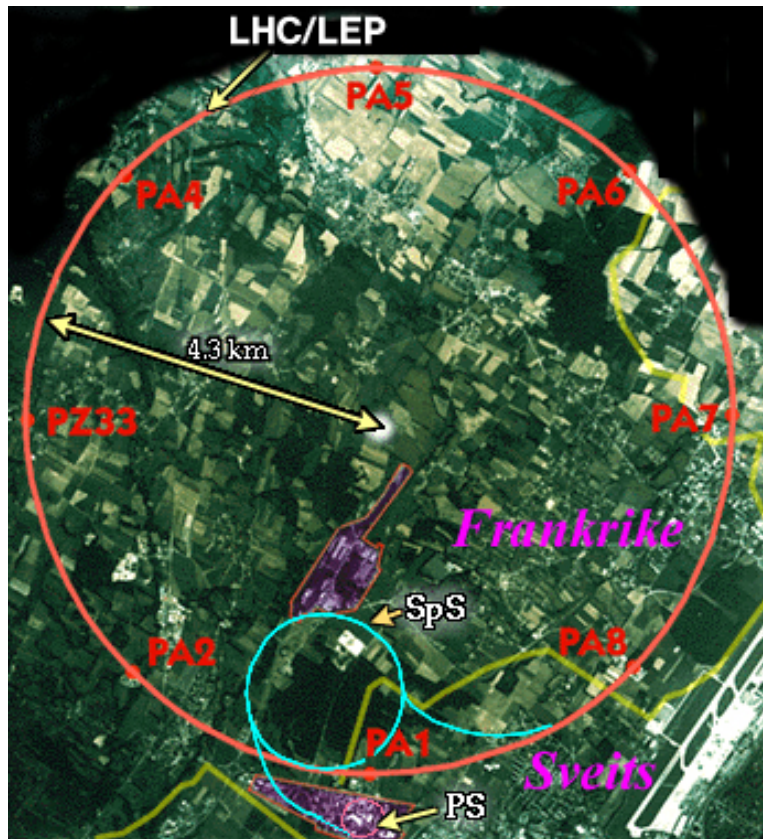


Mean Free Path: Scale Consideration

CERN – LHC:

$U = 2 \cdot 4.3 \cdot \pi = 27 \text{ km}$

$\lambda p = 5 \text{ mm Pa}$



$$\lambda[\text{mm}] = \frac{5}{p[\text{Pa}]}$$

$$p[\text{Pa}] = \frac{5}{\lambda[\text{mm}]} = \frac{5}{2.7 \cdot 10^7} =$$
$$= 1.8 \cdot 10^{-7} \text{ Pa} = 1.8 \cdot 10^{-9} \text{ mbar}$$

Within LHC a pressure of approx. 10^{-9} mbar has to be maintained, to exclude interparticle collisions.

Gas Phase Transport

Clausius' law of distance:

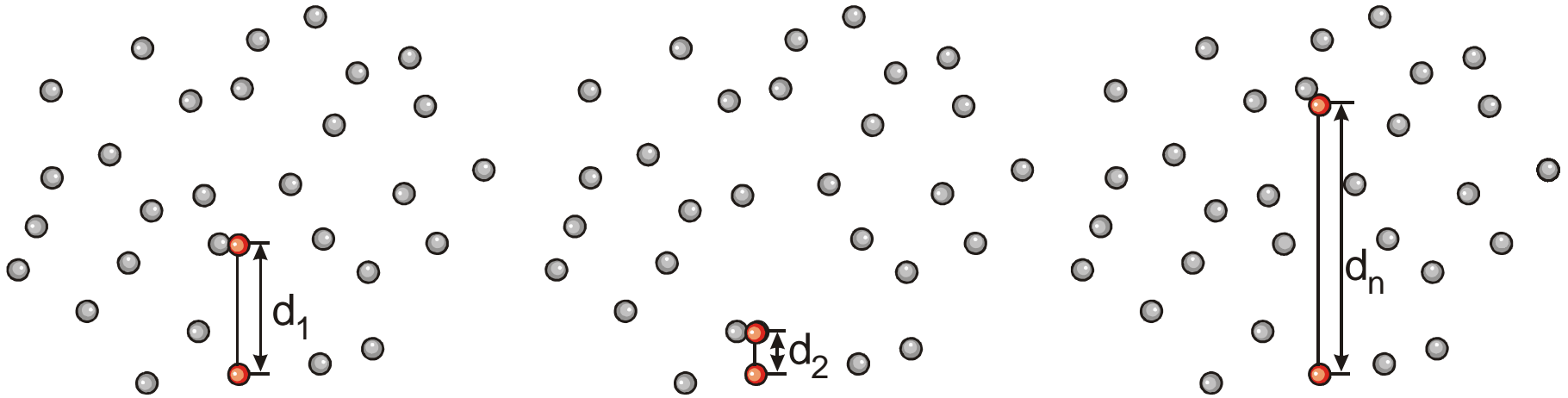
$$N(x) = N(0) \cdot \exp\left[-\frac{x}{\lambda}\right]$$

This means:

- **A significant number of collisions happens before the mean free path is reached.**
- **Only approx. 37% of the particles reach λ without a collision.**
- **The mean free path is only a statistical measure.**

Gas Phase Transport - Statistics

Consider large ensemble of single situations:

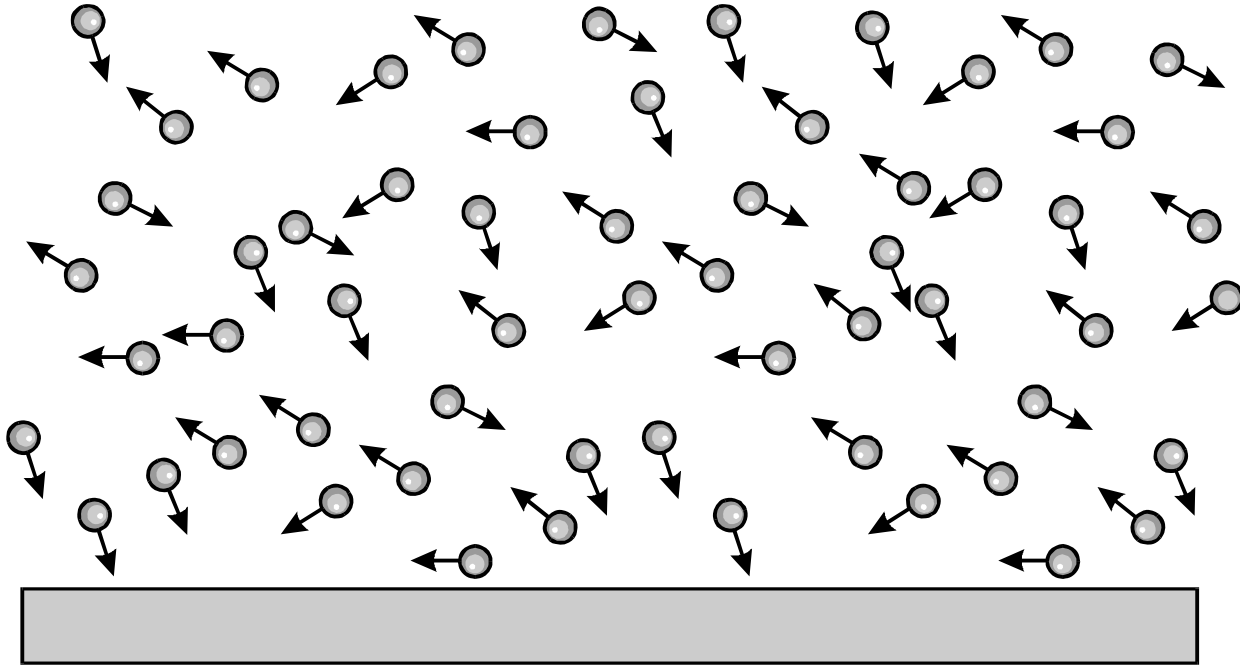


Calculate the expectation value of free throw distances:

$$\langle d \rangle = \frac{\int_0^{\infty} x \cdot \exp\left[-\frac{x}{\lambda}\right]}{\int_0^{\infty} \exp\left[-\frac{x}{\lambda}\right]} = \lambda$$

Areal Impingement Rate I

Initial situation: Gas molecules hit surface

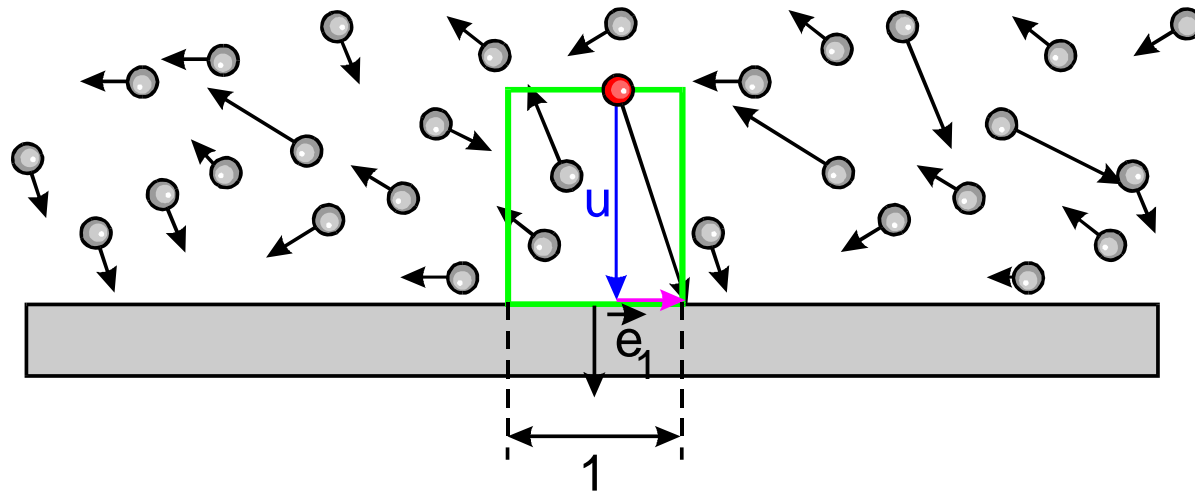


Wanted: number of gas molecules, which hit the unit surface within 1 second.

Areal Impingement Rate II

Approach: cylinder with unit top areas, height u .

Only particles with a **velocity component u** in the direction of \vec{e}_1 , which trespass the top cylinder surface reach the surface within **unit time**.



**Differential areal
impingement rate:**

$$dz_u = \underbrace{u \cdot 1}_{\text{cylinder-volume}} \cdot \underbrace{n}_{\text{particle-density}} \cdot \Phi(u) \cdot du$$

Areal Impingement Rate III

**Differential areal
impingement rate:**

$$dz_u = \underbrace{u \cdot 1}_{\text{cylinder-}} \cdot \underbrace{n}_{\text{particle-}} \cdot \Phi(u) \cdot du$$

volume density

**Total areal
impingement rate:**

$$Z = \int_0^{\infty} dz_u = n \cdot \int_0^{\infty} u \cdot \Phi(u) \cdot du$$

**Maxwell-distribution
of **one** velocity-
component:**

$$\Phi(u) = \sqrt{\frac{m}{2 \cdot \pi \cdot m \cdot k_B \cdot T}} \cdot e^{-\frac{m \cdot u^2}{2 \cdot k_B \cdot T}}$$

Areal impingement rate IV

Calculation of the total areal impingement rate:

$$Z = \int_0^{\infty} dz_u = n \cdot \int_0^{\infty} u \cdot \Phi(u) \cdot du =$$

$$= n \cdot \sqrt{\frac{m}{2 \cdot \pi \cdot k_B \cdot T}} \cdot \underbrace{\int_0^{\infty} u \cdot e^{-\frac{m \cdot u^2}{2 \cdot k_B \cdot T}} du}_{\frac{k_B \cdot T}{m}} = n \cdot \sqrt{\frac{m}{2 \cdot \pi \cdot k_B \cdot T}} \frac{k_B \cdot T}{m} =$$

$$= \left| \frac{N}{V} \right| = n = \frac{p}{k_B \cdot T} = \frac{p}{m} \cdot \sqrt{\frac{m}{2 \cdot \pi \cdot k_B \cdot T}}$$

Areal Impingement Rate Z

$$Z = Z(p, T, m) = \frac{p}{m} \cdot \sqrt{\frac{m}{2 \cdot \pi \cdot k_B \cdot T}}$$

$$m = 5.3 \cdot 10^{-26} \text{ kg (O}_2\text{)}$$

$$k_B = 1,38 \cdot 10^{-23} \text{ J/K}$$

$$T = 300 \text{ K}$$

$$p = 0.1 \text{ Pa}$$

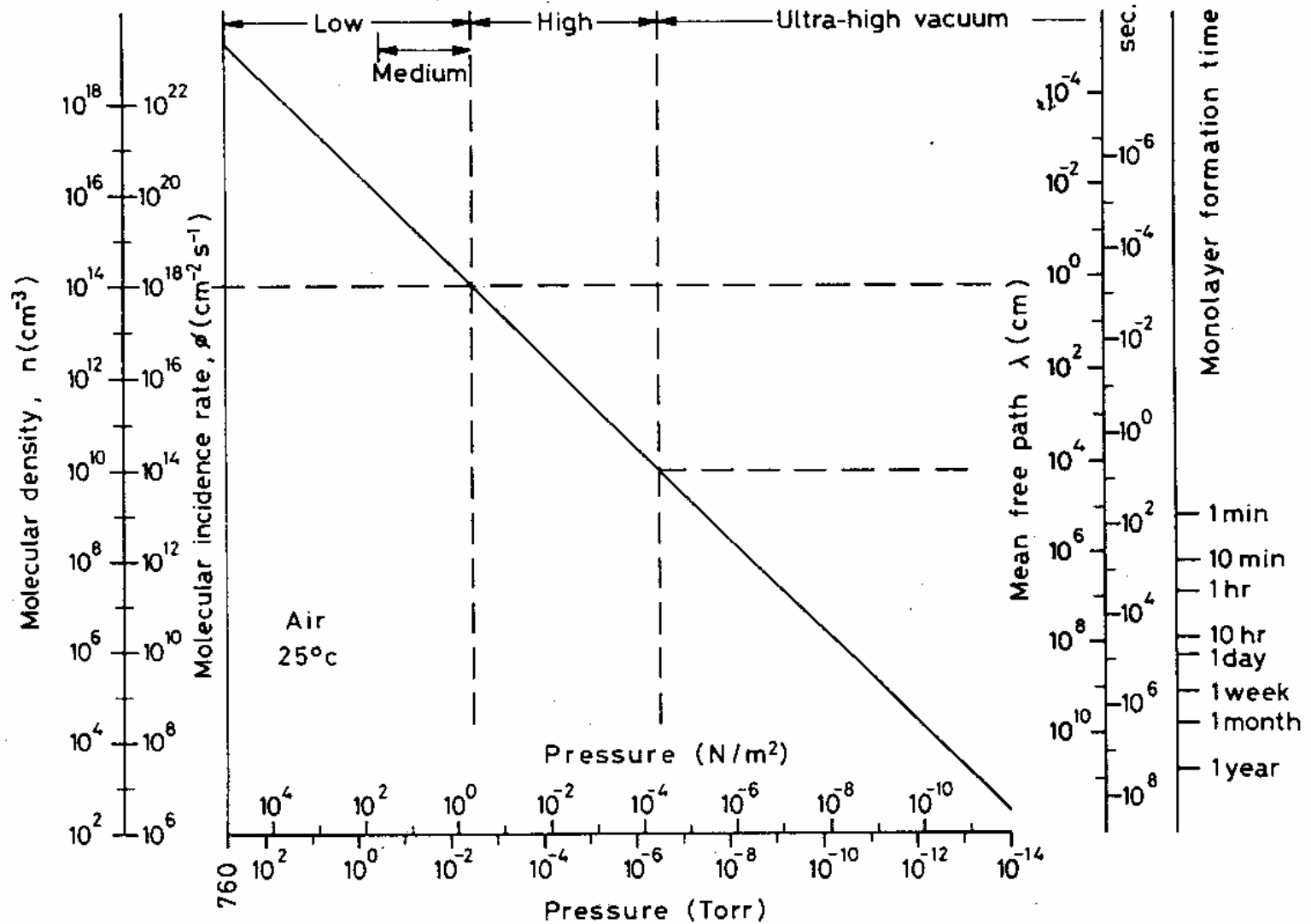
$$p = 10^{-4} \text{ Pa}$$

$$Z = 2.7 \cdot 10^{17} \text{ s}^{-1} \text{ cm}^{-2} \quad Z = 2.7 \cdot 10^{14} \text{ s}^{-1} \text{ cm}^{-2}$$

etwa 270 ML/s

etwa 0.2 ML/s

Areal Impingement Rate - Graphic



Types of Vacuum

Name	Pressure [Pa]	Mean free path [mm]	Coverage time O ₂ , 300K [ML/s]
Rough vacuum	Atm→1	$5 \cdot 10^{-5} \rightarrow 5$	$2.7 \cdot 10^5 \rightarrow 2700$
Fine vacuum	1 → 0.1	5 → 50	2700 → 270
High vacuum (HV)	0.1 → 10^{-5}	50 → $5 \cdot 10^5$	270 → 0.027
Ultra high vacuum (UHV)	$10^{-5} \rightarrow 10^{-10}$	$5 \cdot 10^5 \rightarrow 5 \cdot 10^{10}$	0.027 → $2.7 \cdot 10^{-7}$
Extreme UHV (XHV)	$< 10^{-10}$	$5 \cdot 10^{10} \rightarrow$	$2.7 \cdot 10^{-7} \rightarrow$

$5 \cdot 10^5$ mm \equiv 500 m

$5 \cdot 10^{10}$ mm \equiv 50 000 km (!)

Types of Pumps

● Gas transporting:

- + Rotary pump
- + Diffusion pump
- + Turbomolecular pump

Rough vacuum/fine vacuum

High vacuum

High vacuum

● Gas adsorbing:

- + Cold traps
- + Cryo pumps
- + Sublimation pumps
- + Getter pumps

Fine vacuum

High vacuum/UHV

UHV

UHV

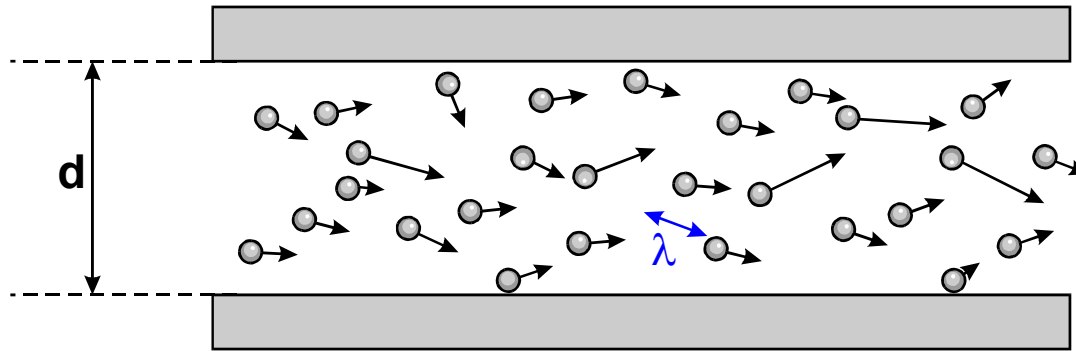
- reactive gases
- + lone getter pumps
inert molecules (activation)

UHV

Flow Types

Flow through a pipe, diameter d :

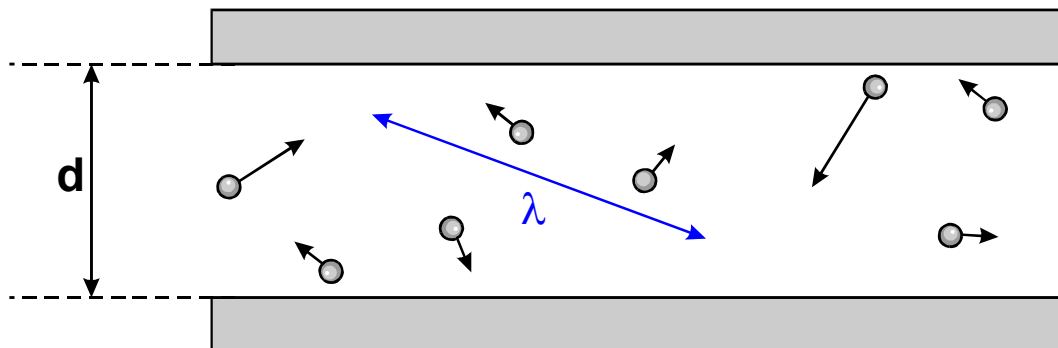
● **Laminar/turbulent:** Rough vacuum/fine vacuum



$$\lambda \ll d$$

Particle collisions
probable,
global flow

● **Molecular:** High vacuum, UHV



$$\lambda \gg d$$

Wall collisions
probable,
no flow

Flow Types and Pumping Systems

- **Efficient in the laminar region:**
 - + Gas transporting pumps:
 - Rotary pump
 - Ejector pump
 - + Rotary pumps, except Turbomolecular pumps

- **Efficient in the molecular region :**
 - + Gas transporting pumps:
 - Diffusion pump
 - Turbomolecular pump
 - + Gas adsorbing pumps

Design Criteria for Vacuum Systems

- **Mean free path λ :**

- + Choice of pump type
- + Pump velocity
- + Dimension of pipe diameters

- **Areal impingement rate Z :**

- + Coverage times (e. g. surface analytics)
- + Impurity content in coatings (ratio of impingement rate of the coating particles and of the background gas particles)

Impurities

Sticking

coefficient α :

$$\alpha = 1 - \frac{Z_{\text{Des}}}{Z}$$

Z ... Impingement rate

Z_{Des} ... Desorption rate

- **High sticking coefficient $\alpha \approx 1$ ($Z_{\text{Des}} \approx 0$):**

Reactive gases:



Complex carbohydrates (pump oil)

- **Low sticking coefficient $\alpha \ll 1$ ($Z_{\text{Des}} \approx Z$):**

Inert gases:

Noble gases



Carbohydrates without reactive groups

Impurities: Example

Coating material:

Al, $m = 4.5 \cdot 10^{-26}$ kg

Rate Al:

10 nm/s = $3 \cdot 10^{19}$ At/(m²s⁻¹)

Impurity:

O₂, $m = 5.3 \cdot 10^{-26}$ kg

Sticking coefficient α :

approx. 1 für Al und O₂

Temperature:

300K

Wanted: Background gas pressure, at which 1% Oxygen is incorporated unto the coating

$$\frac{Z_{\text{O}_2}}{Z_{\text{Al}}} = 10^{-2} = \frac{1}{3 \cdot 10^{19}} \cdot \frac{p}{m_{\text{O}_2}} \cdot \sqrt{\frac{m_{\text{O}_2}}{2 \cdot \pi \cdot k_B \cdot T}}$$

$$p = 10^{-2} \cdot 3 \cdot 10^{19} \cdot m_{\text{O}_2} \cdot \sqrt{\frac{2 \cdot \pi \cdot k_B \cdot T}{m_{\text{O}_2}}} = 1.11 \cdot 10^{-5} \text{ Pa}$$

Design Criteria: Summary

- **Mean free path λ :**

Influences gas dynamics. Even at rather high pressures (10^{-2} Pa) the mean free path reaches the dimensions of average deposition chambers .

- **Areal impingement rate Z:**

Crucial for coating purity. The pressure of the background gas has to be at least in the medium high vacuum to guarantee sufficient film purity.